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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/782,094	02/19/2004	Jae-eun Park	SAM-0483	4756	
7	7590 12/23/2005		EXAM	EXAMINER	
Anthony P. Onello, Jr.			NGUYEN, TUAN H		
MILLS & ONI Suite 605	ELLO LLP	ART UNIT	PAPER NUMBER		
Eleven Beacon Street Boston, MA 02108			2813		
			DATE MAILED: 12/23/200:	s	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applic	ation No.	Applicant(s)				
Office Astion Commence			2,094	PARK ET AL.	(AND			
Office Action Summary		Exami	ner	Art Unit				
			l. Nguyen	2813				
Period fo	The MAILING DATE of this commu	nication appears on	the cover sheet	with the correspondence add	ress			
	• •	OD DEDIVIC CET	T TO EVDIDE 2	MONTU(S) OD TUIDTV (30)	DAVS			
WHI(- Exte after - If N(- Failu Any	ORTENED STATUTORY PERIOD IN CHEVER IS LONGER, FROM THE IN Insions of time may be available under the provision SIX (6) MONTHS from the mailing date of this come of period for reply is specified above, the maximum sure to reply within the set or extended period for representation of the property received by the Office later than three months are patent term adjustment. See 37 CFR 1.704(b).	MAILING DATE OF is of 37 CFR 1.136(a). In no imunication. In statutory period will apply an any will, by statute, cause the	THIS COMMUN be event, however, may ad will expire SIX (6) Ma application to become	NICATION. a reply be timely filed DNTHS from the mailing date of this com ABANDONED (35 U.S.C. § 133).				
Status								
1) 又	Responsive to communication(s) fi	led on 11 October 2	2005.					
•	This action is FINAL .	2b)⊠ This action i						
3)	<u>, </u>							
,	closed in accordance with the prac							
Disposit	ion of Claims							
4)🖂	Claim(s) 1-54 is/are pending in the	application.						
,_	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)	Claim(s) is/are allowed.							
6)⊠	Claim(s) 1-54 is/are rejected.							
7)	Claim(s) is/are objected to.							
8)[Claim(s) are subject to restr	iction and/or electio	n requirement.					
Applicat	ion Papers							
9)[7	The specification is objected to by t	he Examiner.						
• —	The drawing(s) filed on is/are		b) ☐ objected t	o by the Examiner.				
,	Applicant may not request that any obj							
	Replacement drawing sheet(s) including				R 1.121(d).			
11)	The oath or declaration is objected							
Priority	under 35 U.S.C. § 119							
12)🖂	Acknowledgment is made of a clain	n for foreign priority	under 35 U.S.C	. § 119(a)-(d) or (f).				
	⊠ All b) Some * c) None of:							
,	1.⊠ Certified copies of the priorit	y documents have t	peen received.					
	2. Certified copies of the priorit			Application No				
	3. Copies of the certified copies				tage			
	application from the Internati							
* :	See the attached detailed Office acti	on for a list of the c	ertified copies n	ot received.				
Attachmer	nt(s)							
	ce of References Cited (PTO-892)			v Summary (PTO-413)				
	ce of Draftsperson's Patent Drawing Review mation Disclosure Statement(s) (PTQ-1449 o			o(s)/Mail Date Informal Patent Application (PTO-	152)			
Pape	er No(s)/Mail Date <u>5/04, 7/04, 1/05, 2/05, 3/05</u>	6105	6) Other:		•			
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DETAILED ACTION

Double Patenting

The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. A nonstatutory obviousness-type double patenting rejection is appropriate where the conflicting claims are not identical, but at least one examined application claim is not patentably distinct from the reference claim(s) because the examined application claim is either anticipated by, or would have been obvious over, the reference claim(s). See, e.g., In re Berg, 140 F.3d 1428, 46 USPQ2d 1226 (Fed. Cir. 1998); In re Goodman, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); In re Longi, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); In re Van Ornum, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); In re Vogel, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and In re Thorington, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) or 1.321(d) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent either is shown to be commonly owned with this application, or claims an invention made as a result of activities undertaken within the scope of a joint research agreement.

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

Claims 1-54 are provisionally rejected on the ground of nonstatutory obviousness-type double patenting as being unpatentable over claims 1-43 of copending Application No. 10/459,943 in view of Werkhoven et al..

Copending Application No. 10/459,943 discloses substantially the claimed method for forming a silicon dioxide by ALD except the use of a halogen or NCO-substituted siloxane as a silicon source; however, Werkhoven et al., in a related method for forming a thin film by atomic layer deposition, col. 9, lines 49-59, teaches the use of a halogen or NCO-substituted siloxane as a silicon source for forming a layer of silicon dioxide.

It would have been obvious to one having ordinary skill in the art at the time the invention was made to have used the teachings from Werkhoven et al. in forming silicon dioxide as in the copending Application No. 10/459,943 since it is a well-known and commercial available material for use as a silicon source in semiconductor processing art.

This is a provisional obviousness-type double patenting rejection.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-6, 9-12, 18-20 are rejected under 35 U.S.C. 102(e) as being anticipated by Werkhoven et al..

With respect to claims 1, 21, Werkhoven et al., col. 9, lines 35-59 teaches the use of a halogen or NCO substituted siloxane as a first reactant onto the substrate to form a chemisorbed layer (col. 9, lines 43-44, 50-55); feeding a second reactant onto the chemisorbed layer to form the silicon dioxide film on the substrate (col. 10, second paragraph).

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With respect to claims 2-4, see col. 9, lines 50-54 wherein the siloxane represented by the formula $Si_yO_{y-1}L_{2y+2}$ where y is an integer of 2-4, and L is a chemical group selected from F, Cl, Br, I or NCO.

With respect to claims 5, 6, see col. 10, second paragraph wherein the second reactant comprises an oxidant, preferably H₂O (see also col. 7, line 18 for the oxidant source gas).

With respect to claims 9, 20, see col. 9, lines 20-23 for the reaction take place at room temperature.

With respect to claim 10, see col. 9, lines 17-19 for the pressure range.

With respect to claim 11, see col. 9, lines 35-42 and fig. 7 for the carrier gas flow.

With respect to claim 12, see col. 10, fourth paragraph for the continuous deposition of more than two monolayers until a desired thickness is attained.

With respect to claims 18, 19, see col. 10, lines 22-39, fig. 7, purge step 303 for the step of purging.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tuan H. Nguyen whose telephone number is 571-272-1694. The examiner can normally be reached on 9AM-5:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Tuan H. Nguyen
Primary Examiner
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